

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of

Satoshi SASAKI et al.

Application No.:

10/663,811

Filed: September 23, 2003

Docket No.: 117164

For:

PIEZOELECTRIC CERAMIC COMPOSITION PIEZOELECTRIC ELEMENT AND

PRODUCTION METHOD THEREFOR

CLAIM FOR PRIORITY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The benefit of the filing dates of the following prior foreign applications filed in the following foreign country(ies) is hereby requested for the above-identified patent application and the priority provided in 35 U.S.C. §119 is hereby claimed:

Japanese Patent Application No. 2002-272037 filed on September 18, 2002 Japanese Patent Application No. 2003-096661 filed on March 31, 2003

In support of this claim, certified copies of said original foreign applications:

are filed herewith.

It is requested that the file of this application be marked to indicate that the requirements of 35 U.S.C. §119 have been fulfilled and that the Patent and Trademark Office kindly acknowledge receipt of these documents.

Respectfully submitted,

. Oliff

Registration No. 27,075

Joel S. Armstrong

Registration No. 36,430

JAO:JSA/mlo

Date: July 19, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461